

## ATTORNEY DOCKET NO. Q57433 PATENT APPLICATION

G. Stanly

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kiyoshi TAKEI, et al.

Appln. No.: 09/482,099

Examiner: Delma R. Flores

Filed: January 13, 2000

For: DISTRIBUTED FEEDBACK TYPE SEMICONDUCTOR LASER DEVICE AND

METHOD OF MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

This paper is responsive to the Office Action mailed on September 11, 2001, for the above-identified application.

Applicants elect Group 1, claims 1-3, without traverse.

Applicants reserve the right to file a Divisional Application directed to non-elected Group

2.

Respectfully submitted,

Group Art Unit: 2877

Darryl Mexic

Registration No. 23,063

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